

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 28, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG671461625

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

12.65 X 6.63 X 4.26 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.08 CARATS

G

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

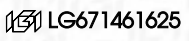
EXCELLENT

EXCELLENT

NONE

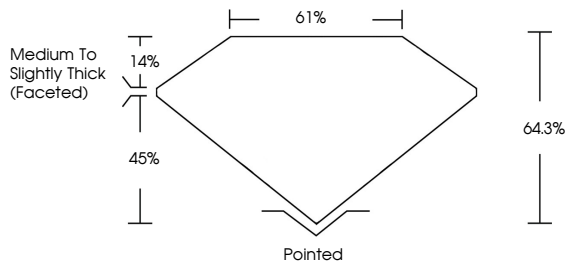
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

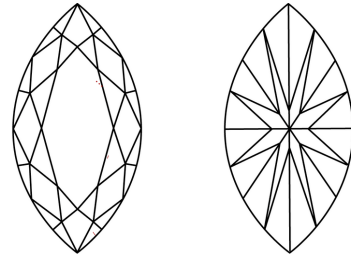


IGI LG671461625

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

LABORATORY GROWN DIAMOND REPORT



December 28, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG671461625

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

12.65 X 6.63 X 4.26 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.08 CARATS

G

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

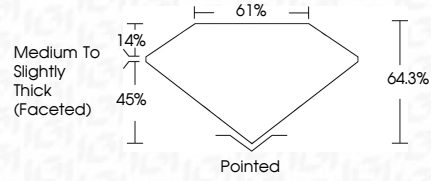
EXCELLENT

NONE

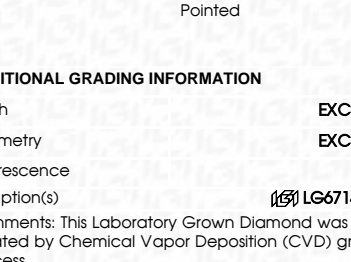
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS






KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

IGI





© IGI 2020, International Gemological Institute

FD - 10 20

December 28, 2024

IGI Report No LG671461625

MARQUISE BRILLIANT

12.65 X 6.63 X 4.26 MM

2.08 CARATS

G

Color Grade

Clarity Grade

Table

Depth

Girdle

VVS 2

VVS 2

64.3%

61%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG671461625

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

IGI LG671461625

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa